VISIBLE AND INFRARED RARE-EARTH ACTIVATED ELECTROLUMINESCENCE FROM ERBIUM DOPED GaN

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Cite this article as: MRS Internet J. Nitride Semicond. Res. 4S1, G11.3 (1999)

ABSTRACT

Room temperature visible and IR light electroluminescence (EL) has been obtained from Er-doped GaN Schottky barrier diodes. The GaN was grown by molecular beam epitaxy on Si substrates using solid sources (for Ga and Er) and a plasma source for N_2 . Transparent contacts utilizing indium tin oxide were employed. Strong green light emission was observed under reverse bias due to electron impact excitation of the Er atoms. Weaker emission was present under forward bias. The emission spectrum consists of two narrow green lines at 537 and 558 nm and minor peaks at 413, 461, 665, and 706 nm. There is also emission at 1000 nm and 1540 nm in the IR. The green emission lines have been identified as Er transitions from the ${}^4H_{11/2}$ and ${}^4H_{13/2}$ ground state. The IR emission lines have been identified as transitions from the ${}^4H_{11/2}$ and ${}^4H_{13/2}$ levels to the ${}^4H_{13/2}$ ground state. EL intensity for visible and IR light has a sub-unity power law dependence on bias current. An external quantum efficiency of 0.1% has also been demonstrated under a reverse bias current of 3.85 mA.

INTRODUCTION

The recent groundbreaking work¹ by Nakamura in GaN based LEDs and laser diodes has resulted in shorter wavelength semiconductor visible light emission. At the same time novel work is being conducted using rare earth elements as sources of light emission. Results based on glasses^{2,3} are exciting for display, memory and discrete device technologies. Rare-earth (RE) doped Silicon based devices^{4,5,6,7,8,9} have improved so that room temperature emission is now possible. III-V semiconductors doped with rare-earth elements have also been used^{10,11,12,13,14,15,16,17,18} and have advantages compared to narrow bandgap materials¹⁹. The advantage of Nakamura's devices is their extremely high quantum efficiency¹ (~5%), whereas RE doped devices offer multiple color emission, wavelength-limited only by the RE element(s) chosen and not by the band gap energy of the semiconductor. Our recent work now indicates the

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1. REPORT DATE 1999	DATE 2. REPORT TYPE			3. DATES COVERED 00-00-1999 to 00-00-1999	
4. TITLE AND SUBTITLE Visible and Infrared Rare-Earth Activated Electroluminescence from Erbium Doped GaN				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) University of Cincinnati,Nanoelectronics Laboratory,Cincinnati,OH,45221-0030				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAIL Approved for publ	LABILITY STATEMENT ic release; distributi	ion unlimited			
13. SUPPLEMENTARY NO The original docum	otes nent contains color i	images.			
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Form Approved OMB No. 0704-0188 possibility of combining the advantages of these two very different approaches in order to realize highly efficient full color displays in a single semiconductor host or very simple discrete devices using RE-doped GaN. We have recently reported strong visible (green) RE-activated PL from insitu Er-doped GaN grown by MBE on sapphire²⁰ and on Si²¹ substrates. The same strong green RE-activated emission was also observed²² in EL from simple Al Schottky diodes on GaN:Er and from more sophisticated devices using indium tin oxide(ITO) transparent contacts. In this paper we report on the performance characteristics of Er-doped GaN LEDs emitting in both the visible and IR regions.

EXPERIMENT

The GaN:Er light emitting devices can be operated in two different ways. One way is to use both top side contacts, which consist of patterned indium tin oxide (ITO), for both positive and negative electrodes. Under reverse bias, the smaller, emitting electrode is negative and the larger electrode is positive. The devices can also be operated by making an ohmic contact to the backside of the Si. This method is interesting because current actually flows across the GaN/Si heterojunction. The devices behave very similarly in both modes and all data presented here were taken using top-side contacts.

The Er-doped GaN was grown using a Riber MBE-32 system on 2 inch p-Si (111) substrates and on 2 inch sapphire. Solid sources were used to supply the Ga and Er fluxes, while an STVA RF-plasma source supplied atomic nitrogen. Prior to MBE growth, the Si substrate was cleaned in acetone, methanol and DI water, followed by HF to remove all native oxide. After insertion into the MBE chamber, a thin, low temperature GaN buffer layer was first grown followed by a GaN:Er layer. The GaN layers were grown at a substrate temperature between 700- 750°C. The ITO contacts were formed using RF-sputtering in conjunction with a lift-off process. The ITO target had a composition of 90% In_2O_3 and 10% SnO_2 . The sputtering was performed at 5 mTorr with 133 W of RF power, resulting in -183 volts of DC bias. Under these conditions, the deposition rate was ~70 Å/min. The ITO film was ~4200 Å thick and had a sheet resistance of 30 Ω /square as-deposited. Subsequent annealing in a nitrogen atmosphere for 2 minutes at 450 °C reduced the sheet resistance to ~5.5 Ω /square with transmission of ~92% at a wavelength of 537 nm and ~3% at 1.5 μ m. Electroluminescence data were collected using either an Acton Research spectrometer or an Ocean Optics fiber optic spectrometer. Optical power

measurements were made using a Newport 1818-SL/CM optical power meter. All measurements reported were made at room temperature.

RESULTS

Fig. 1 shows a photograph of a GaN:Er LED in operation using a standard probe station. In this photo, negative bias is being applied to the green light emitting electrode, resulting in a current of 19 mA. The device shown here is fairly large (2 mm radius) because it was designed to make spectral data collection using an optical fiber more practical. An optical fiber can be placed in the immediate vicinity of the device, while still leaving enough room for an electrical probe tip. The emission intensity and color is uniform across the diode and the emitted light is easily seen in a normally lit room. Fig. 2 shows the difference in spectral shape between a commercial GaP-based device and our GaN:Er device. Notice that the conventional GaP LED is shifted more toward the yellow end and has an FWHM of 30 nm. By comparison, the GaN:Er green device has an FWHM of 5-6 nm and emits in the middle of the green range. The GaP LED was biased at 2 mA and the GaN:Er device was biased at 10 mA during these measurements. The peaks represent the actual signal intensity. Minor peaks at 413 nm and 665 nm are also present in the GaN:Er device spectrum. Fig. 3 shows the IR emission spectrum from a GaN:Er device biased at 75 volts and 19 mA. We have identified the 1.5 μm radiation preiously.²³ The 1 μm peak corresponds to a transition from ⁴I_{11/2} to the ⁴I_{15/2} ground state. It has an FWHM of ~25 nm. The

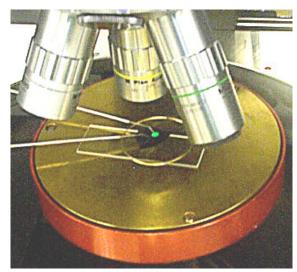


Fig. 1 Photograph of visible rare-earth-activated emission from ITO/GaN:Er device.

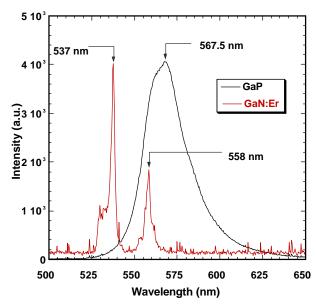


Fig. 2 Emission spectrum in the visible range from a commercial green GaP-based LED vs. our GaN:Er device.

visible and IR optical power emitted and detected from a GaN:Er LED are plotted as a function of bias current in Fig. 4. The visible optical power at the detector has a sub-unity power law dependence on bias current over the measurement range, reaching a value of 212 nW at 19 mA. The IR optical power also increases with a power law dependence over the measurement range reaching a value of 12.3 nW at 19 mA. It is important to note that the ITO electrodes for these experiments were optimized for green light, but the transmission in the IR can be increased by processing the ITO differently. The ITO layer transmits about 3% of the IR light emitted and about 92% of the visible green light. With this in mind, our devices probably emit slightly more IR light than visible light, however, the ITO absorbs most of the IR light. During these measurements, a Si photodetector was placed 2.0 cm above the device. Assuming a point source of radiation, and uniform hemispherical emission, the visible optical power generated at the device is estimated to be 5.33 µW for 10 mA of applied reverse bias. Under these conditions, the external quantum efficiency at 537 nm is estimated to be 0.012%. However, a maximum external quantum efficiency of 0.1% has been reached for a GaN:Er device grown on sapphire. This device was operated at 155 Volts and 3.85 mA, and it was also used to take the data presented in Fig. 5. Fig. 5 summarizes the EL peaks that we have observed to date. The number of observable peaks increases with increasing applied power. The following peaks have been observed during EL of GaN:Er: 413, 461, 537, 558, 665, 671, 706, 1000, 1515, 1539, 1555nm. The EL peaks at 537 and 558 nm are dominant in the visible range and correspond to transitions from the ²H_{11/2}. and the $^4S_{3/2}$ to the $^4I_{15/2}$ ground state. It is interesting to note that the 706 nm line probably

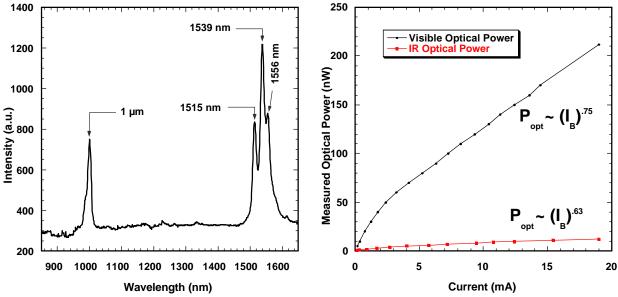


Fig. 3 Rare-earth activated emission spectra in the IR range from an ITO/GaN:Er device.

Fig. 4 Visible and IR optical power as a function of bias current.

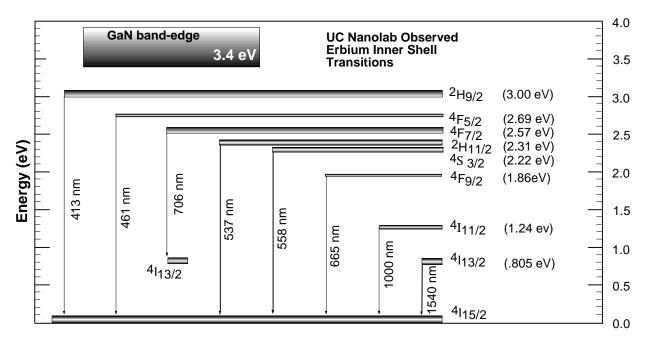


Fig. 5 Summary of the observed atomic energy levels of Rare-earth-activated emission in the visible and IR range from an ITO/GaN:Er device.

corresponds to a transition from the ${}^4F_{7/2}$ to the ${}^4I_{13/2}$ state instead of the normal ground state. This is the only intermediate transition we have observed. In addition, it is interesting that the ${}^4I_{9/2}$ (~1.55 ev above the ground state) level, a common transition in other host materials, is not observed in our material.

SUMMARY

In summary, we have reported visible and IR rare-earth-activated electroluminescence of Er-doped GaN. The use of ITO as a contact provides a fast and easy way to make devices, and also increases the amount of visible light output from the device. Both IR and visible EL peaks show narrow linewidths. Our devices transmit appreciably more visible than IR light, however the use of ITO as a contact material is not ideal for IR light emission under the specific conditions that the ITO was deposited. Future work will focus on reducing the operating voltage and increasing the external quantum efficiency of the devices. This work was supported in part by a BMDO/ARO contract (L. Lome and J. Zavada) and AASERT grants. The authors would like to acknowledge the support and encouragement of J. Zavada. Equipment support was provided by an ARO URI grant and the Ohio Materials Network.

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